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## BIB DATA SHEET

CONFIRMATION NO. 6654

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/589,077	03/09/2007 RULE	438	2822	294455US0PCT
<b>APPLICANTS</b> Hiroaki Takeuchi, Nagoya-shi, JAPAN; Satoshi Hattori, Nagoya-shi, JAPAN; Hiroshi Suzuki, Nagoya-shi, JAPAN; Katsuyoshi Harada, Nagoya-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP05/02425 02/17/2005				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2004-040613 02/17/2004				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 04/13/2007				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/KEVIN M PICARDAT/</u> Examiner's Signature	<input type="checkbox"/> Met after Allowance <u>Initials</u>	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 1	<b>TOTAL CLAIMS</b> 5
<b>INDEPENDENT CLAIMS</b> 1				
<b>ADDRESS</b> OBLON, SPIVAK, MCCLELLAND MAIER & NEUSTADT, P.C. 1940 DUKE STREET ALEXANDRIA, VA 22314 UNITED STATES				
<b>TITLE</b> Method for producing silicon oxide film				
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	